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| | Telephone: 571-272-1033 |
| Total Pages, including cover lette | er: <u>13</u> |
| fax number: <u>571-</u> | 273-8300 |
| PGSPONSE T Document Transmitted: <u>ac 4 06 (</u> | TO NOTICE OF NON-COMPLIANCE DATED |
| Applicant: COUINS et al. | Examiner: MAUREEN ARANCEBIA |
| Serial No.: 10/646,527 | Group Art Unit: 1763 |
| Filed: 08 22 2003 | Docket No.: 006915 P07 |
| Title: PLASMA IMMERSION I | IN JUPLANTATION SYSTEM |
| ENCLUDING A PLASMA SON | RCE HAVING LOW DISSOCI ATION |
| AND LOW MINIMUM PLASMA | T VOLTAGE |
| | |
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| Printed Name: SHEUY H | ART |
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PATENT

Attorney Docket No.: 006915/P07

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kenneth COLLINS, et al.

Group Art Unit: 1763

Entitled: PLASMA IMMERSION ION

IMPLANTATION SYSTEM INCLUDING A

PLASMA SOURCE HAVING LOW

DISSOCIATION AND LOW MINIMUM PLASMA:

VOLTAGE

Examiner: Maureen G.

Arancibia

Serial No.: 10/646,527

Filing Date: August 22, 2003

RESPONSE TO NOTICE OF NON-COMPLIANCE DATE 06/19/2006

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 19, 2006, please amend the status identifiers of Claims 6, 7, 8, and 9 as follows: